



The University of Michigan Radiation Laboratory
3228 EECS Building
Ann Arbor, Michigan 48109-2122 USA
Tel: (734) 483-4211
Fax: (734) 647-2106
e-mail: liepa@umich.edu

Re: Certification for Williams USA, LLC
FCC ID: 2ABU9-504I
IC: 11768A-504I

REQUEST FOR CONFIDENTIALITY

Pursuant to USA FCC 47 CRF 0.457(d) and 0.459 and Canada IC RSP-100, Section 10, Williams USA, LLC requests that a part of the subject application be held confidential. Williams USA, LLC has spent substantial effort in developing this product and it is one of the first of its kind in industry. Having the subject information easily available to "competition" would negate the advantage they have achieved by developing this product. Not protecting the details of the design will result in financial hardship.

| <u>Exhibit</u> | <u>Conf. Type</u> | <u>Rational</u> |
|--------------------------|-------------------|---|
| Exh 04 - Block Diagram | Permanent | Includes proprietary internal oscillator frequency information. |
| Exh 05 - Schematics | Permanent | Includes proprietary design information |
| Exh 10 - BOM + Placement | Permanent | Includes proprietary design information |

Permanent Confidentiality: Williams USA, LLC requests that any exhibits listed above as permanently confidential be permanently withheld from public review.

Short-Term Confidentiality (FCC Only): Williams USA, LLC requests that any exhibits selected above as short term confidential be withheld from public view for a period of 45 days from the date of the Grant of Equipment Authorization and prior to marketing.

If there are any questions regarding the application or testing performed, please contact us at the above address or call (734) 483-4211, or e-mail liepa@umich.edu.

Sincerely,

A handwritten signature in black ink that reads "Valdis V. Liepa".

Valdis V. Liepa
The University of Michigan Radiation Laboratory